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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				Application Number	10/574,015
				Filing Date	March 29, 2006
				First Named Inventor	Hiromi AKIYOSHI et al.
				Group Art Unit	3663
				Examiner Name	Redhwan K. Mawari
Sheet	1	of	1	Attorney Docket Number	0670-7073

U.S. PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			

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/R.M./		JP	11-201766			07/30/1999		Abst.
/R.M./		JP	2000-346667			12/15/2000		Abst.
/R.M./		JP	2004-309368			11/04/2004		Abst.
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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/R.M./		Office Action (Japanese Patent Application No. 2004-039334) dated May 29, 2008.	Full
/R.M./		Office Action (Japanese Patent Application No. 2004-039337) dated May 29, 2008.	Full
/R.M./		Office Action (Japanese Patent Application No. 2004-039338) dated May 29, 2008.	Full
/R.M./		Office Action (Japanese Patent Application No. 2004-039340) dated May 29, 2008.	Full

Examiner Signature	/Redhwan Mawari/	Date Considered	12/23/2008
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